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SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/589,390	08/15/2006	438	2892	1035-650		
RULE						
APPLICANTS Shigeki Imai, Nara-shi, JAPAN; Kazuhiko Inoguchi, Nara-shi, JAPAN; Hikaru Kobayashi, Kyoto-shi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/02352 02/16/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-038888 02/16/2004 JAPAN 2004-093703 03/26/2004 JAPAN 2004-093695 03/26/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/09/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /PHUC T DANG/ Acknowledged Examiner's Signature		<input checked="" type="checkbox"/> Met after Allowance PD Initials	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
			JAPAN	26	34	4
ADDRESS						
NIXON & VANDERHYE, PC 901 NORTH GLEBE ROAD, 11TH FLOOR ARLINGTON, VA 22203 UNITED STATES						
TITLE						
THIN FILM TRANSISTOR, METHOD OF MANUFACTURING SAME, DISPLAY DEVICE, METHOD OF MODIFYING AN OXIDE FILM, METHOD OF FORMING AN OXIDE FILM, SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE						
FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		
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